

Appl. No. 09/530,588
Reply to Office Action of July 18, 2003



DOCKET NO. 2312-0866-2PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF:

HAYASHI OTSUKI ET AL. : GROUP: 2814

SERIAL NO: 09/530,588 : EXAMINER: QUACH, T.

FILED: MAY 5, 2000 :

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FOR: METHOD OF FORMING SEMICONDUCTOR WIRING STRUCTURES

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AMENDMENT UNDER 37 CFR 1.116

TJ
11/11/03
COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

SIR:

In response to the Office Action mailed July 18, 2003, please amend the above-identified patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Amendments to the Abstract begin on page 7 of this paper.

Remarks/Arguments begin on page 8 of this paper.